



PATENT
3885-0103P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Yoshinobu ONO et al. Conf.: 2546
Appl. No.: 10/046,741 Group: 2812
Filed: January 17, 2002 Examiner: S. Mulpuri
For: METHOD FOR FABRICATING III-V COMPOUND
SEMICONDUCTOR

AMENDMENT UNDER 37 C.F.R. 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 9, 2004

Sir:

In reply to the Office Action dated September 9, 2003, the period for response having been extended by one (1) month until January 9, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes amendments to the specification, amended claim set and remarks.

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